

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Takanobu TAKEDA et al.

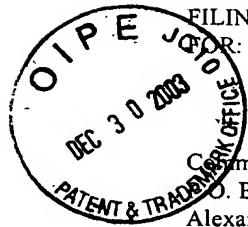
SERIAL NO: 10/085,935

GAU: 1752

EXAMINER: Sin J. Lee

FILING DATE: March 1, 2002

FOR: SILICON-CONTAINING POLYMER, RESIST COMPOSITION AND PATTERNING PROCESS



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TC 1700

AMENDMENT TRANSMITTAL

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SIR:

Transmitted herewith is an amendment in the above-identified application.

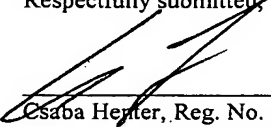
- ☐ No additional fee is required.
- ☐ Applicant(s) is/are entitled to small entity status.
- ☒ Additional documents filed herewith: Reply

The fee has been calculated below:

CLAIMS	CLAIMS REMAINING		HIGHEST NO. PREVIOUSLY PAID FOR	NO. OF EXTRA CLAIMS	RATE		CALCULATIONS
TOTAL	36	MINUS	20	16	x	\$18 =	\$288.00
INDEPENDENT	4	MINUS	3	1	x	\$86 =	\$86.00
	<input type="checkbox"/> MULTIPLE DEPENDENT CLAIMS						
	TOTAL OF ABOVE CALCULATIONS						\$374.00
	<input type="checkbox"/> REDUCTION BY 50% FOR FILING BY SMALL ENTITY						\$0.00
	<input type="checkbox"/> RECORDATION OF ASSIGNMENT						\$0.00
	TOTAL						\$374.00

- ☒ A check in the amount of \$374.00 is attached.
- ☒ Please charge any additional fees for the papers being filed herewith and for which no check is enclosed herewith, or credit any overpayment to Deposit Account No. 13-3402. A duplicate copy of this sheet is enclosed.
- ☒ If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. § 1.136, and any additional fees required under 37 C.F.R. § 1.36 for any necessary extension of time may be charged to Deposit Account No. 13-3402. A duplicate copy of this sheet is enclosed.

Respectfully submitted,


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Attorney/Agent for Applicants

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Date: December 30, 2003



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In re application of :

Takanobu TAKEDA et al. :

Serial No.: 10/085,935 :

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Title: SILICON-CONTAINING POLYMER, RESIST COMPOSITION AND
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Group Art Unit.: 1752

Examiner: LEE, Sin J.

REPLY

Commissioner for Patents
P.O. Box 1450
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SIR:

In response to the Office Action dated October 7, 2003, please amend the claims as follows and consider the remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 16 of this paper.

01/06/2004 ZJUHA1 00000111 10085935

01 FC:1201
02 FC:1202

86.00 OP
288.00 OP